

Amendments to the Claims:

In the claims:

Please CANCEL claims 8-9, 11 and 16 without prejudice such that the pending claims will read as follows:

Claim 1 (Original): A standardized facilities box comprising:

a box;

a mechanism for mounting the box to a support pedestal of a semiconductor fabrication facility; and

one or more mechanisms for selectively coupling any one of a set of add-on features within the box.

Claim 2 (Original): The standardized facilities box of claim 1 further comprising an add-on feature coupled to the one or more mechanisms for selectively coupling.

Claim 3 (Original): The standardized facilities box of claim 2 wherein the add-on feature comprises a partition.

Claim 4 (Original): The standardized facilities box of claim 2 wherein the add-on feature comprises a document storage compartment.

Claim 5 (Original): The standardized facilities box of claim 2 wherein the add-on feature comprises a sensor and a warning indicator.

Claim 6 (Original): The standardized facilities box of claim 2 wherein the add-on feature comprises an automatic lockout mechanism.

Claim 7 (Original): The standardized facilities box of claim 2 wherein the add-on feature comprises a tool storage mechanism.

Claims 8-9 (Canceled).

Claim 10 (Original): The standardized facilities box of claim 2 wherein the add-on feature comprises a mechanical locating mechanism for a facilities connection.

Claim 11 (Canceled).

Claim 12 (Original): The standardized facilities box of claim 2 wherein the add-on feature comprises an openable cover.

Claim 13 (Original): The standardized facilities box of claim 2 wherein the add-on feature comprises floor lighting.

Claim 14 (Original): The standardized facilities box of claim 2 wherein the add-on feature comprises a lifting mechanism adapted to lift and/or lower the box into or from a position for mounting the box to a support pedestal.

Claim 15 (Original): The standardized facilities box of claim 2 wherein the add-on feature comprises a lifting mechanism adapted to lift and/or lower an item to or from the box.

Claim 16 (Canceled).

Claim 17 (Original): A facilities box comprising:
a box adapted to house facilities connections therein;
a mechanism for mounting the box to a support pedestal
of a semiconductor fabrication facility; and

a lifting mechanism coupled to the box adapted to lift and/or lower the box into or from a position for mounting the box to a support pedestal.

Claim 18 (Original): A facilities box comprising:

- a box adapted to house facilities connections therein;
- a mechanism for mounting the box to a support pedestal of a semiconductor fabrication facility; and
- a lifting mechanism adapted to lift and/or lower an item to or from the box.

Claim 19 (Original): A facilities box comprising:

- a box adapted to house facilities connections therein;
- a mechanism for mounting the box to a support pedestal of a semiconductor fabrication facility; and
- a sensor.

Claim 20 (Original): A facilities box comprising:

- a box adapted to house facilities connections therein;
- a mechanism for mounting the box to a support pedestal of a semiconductor fabrication facility; and
- an exhaust mechanism.

Claim 21 (Original): A facilities box comprising:

- a box adapted to house facilities connections therein;
- a mechanism for mounting the box to a support pedestal of a semiconductor fabrication facility;
- a cover coupled to the box; and
- a lockout mechanism adapted to lock the cover of the box.

Claim 22 (Original): The facilities box of claim 21 wherein the lockout mechanism is a lockout tag out mechanism.

Claim 23 (Original): A method of standardizing a semiconductor fabrication facility, comprising:

indicating a location within a fabrication facility for installing a facilities box;

providing a standardized facilities box having a mechanism for selectively coupling any one of a set of add-on features to the standardized facilities box;

providing a plurality of add-on features; and

specifying which add-on feature should be selectively coupled to which selective coupling mechanism of the standardized facilities box.